

# High speed MOVPE for InGaP/GaAs multijunction solar cells

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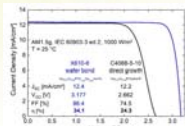
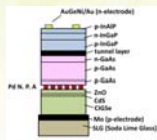
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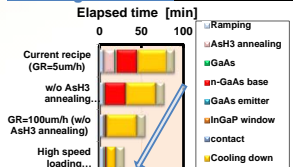
## REASERCH BACKGROUND

To decrease cost of III-V semiconductor solar cells

- Substrate cost: substrate reuse and epi-growth on inexpensive substrates

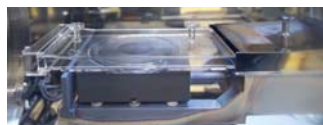


MOVPE growth time for a GaAs cell



- Epitaxial cost: high speed MOVPE and improve material utilization

## METHOD

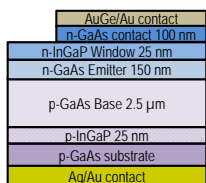


- Taiyo Nippon Sanso, HR3335
  - Horizontal MOVPE reactor
  - Standard precursors
  - Narrow flow channel to enhance the growth rate (GR)



- Standard growth conditions: in this work
  - Total gas flow: 10 SLM
  - Reactor pressure: 15 kPa
  - Our recent study indicates that a slightly high pressure is good for InGaP growth.

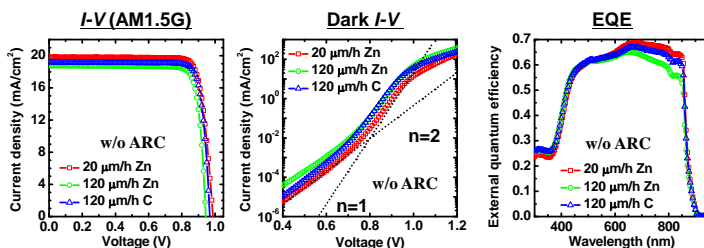
## OPTIMIZATION OF 120-μm/h GROWN GaAs 1J SOLAR CELLS



Schematic and details of GaAs 1J

- A reference GaAs cell grown with GR of GaAs base layer at 20 μm/h
  - V/III ratio 20 using Zn dope
- 2 samples of 120 μm/h grown cells
  - V/III ratio 20 using Zn dope
  - V/III ratio 3 using carbon auto-dope

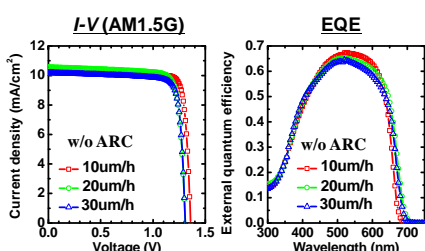
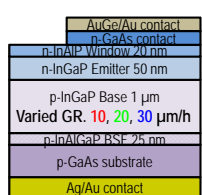
GR (μm/h)	V <sub>oc</sub> (V)	J <sub>sc</sub> (mA/cm <sup>2</sup> )	FF	η (%)	J <sub>01</sub> (mA/cm <sup>2</sup> )	J <sub>02</sub> (mA/cm <sup>2</sup> )
20	0.99	19.82	0.836	16.35	4.49×10 <sup>-16</sup>	1.41×10 <sup>-9</sup>
120 (Zn)	0.94	18.76	0.852	15.08	1.70×10 <sup>-15</sup>	1.64×10 <sup>-8</sup>
120 (C)	0.97	19.15	0.853	15.82	6.38×10 <sup>-16</sup>	1.28×10 <sup>-9</sup>



- Increase of J<sub>01</sub> and J<sub>02</sub> with GR from 20 to 120 μm/h
  - reduce both V<sub>oc</sub> and J<sub>sc</sub> because of increase in defect density
  - C dope (low V/III) better than Zn dope for 120 μm/h grown cells
  - Native defect in p-GaAs = As antisite → decrease defect by lowering V/III ratio

## EFFECTS OF GROWTH RATE ON InGaP SOLAR CELLS

Schematic of InGaP 1J

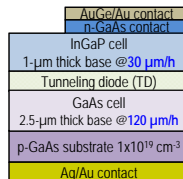


- Increase of W<sub>oc</sub> with GR
  - Degradation of InGaP quality
  - Shunt-like I-V characteristics
  - Not exist in DIV measurement
  - Issue of poor carrier extraction

GR (μm/h)	V <sub>oc</sub> (V)	W <sub>oc</sub> (V)	J <sub>sc</sub> (mA/cm <sup>2</sup> )	η (%)
10	1.36	0.518	10.20	11.92
20	1.31	0.529	10.57	11.43
30	1.31	0.543	10.19	11.13

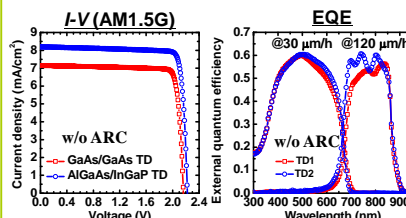
## HIGH SPEED GROWN InGaP/GaAs 2J SOLAR CELLS

Schematic of 2J



- Two combinations of TD used in this work
  - p<sup>+</sup>GaAs(Zn)/n<sup>+</sup>GaAs(Si) and p<sup>+</sup>AlGaAs(C)/n<sup>+</sup>InGaP(Si)

TD	Layer	V/III	T <sub>d</sub> (°C)	Dopant	[Carrier] (cm <sup>-3</sup> )
TD1	p <sup>+</sup> GaAs	20	550	Zn	9.2×10 <sup>19</sup>
	n <sup>+</sup> GaAs	20	650	Si	8.7×10 <sup>18</sup>
TD2	p <sup>+</sup> AlGaAs	3	550	C	1.07×10 <sup>20</sup>
	n <sup>+</sup> InGaP	50	650	Si	1.55×10 <sup>19</sup>



TD	V <sub>oc</sub> (V)	J <sub>sc</sub> (mA/cm <sup>2</sup> )	η (%)
TD1	2.16	7.15	13.49
TD2	2.22	8.19	15.91
TD2 w/ARC	2.26	11.36	22.30

- Sufficient loss in TD1
  - Absorption loss decreased J<sub>sc</sub>
  - Voltage drop across TD1 > TD2

## CONCLUSIONS

- For n-on-p GaAs single junction solar cell, low V/III ratio during high speed grown GaAs base is beneficial for low defect density and allowing carbon auto-doping.
- For both GaAs and InGaP, high speed growth results in decreasing of cell efficiency, which defects and dislocations are responsible.
- InGaP/GaAs 2J solar cells were successfully fabricated with GR of 1-μm thick InGaP and 2.5-μm thick GaAs base layers at 30 and 120 μm/h respectively.

## REFERENCES

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